

4th International Workshop on Advanced Atomic Force Microscopy Techniques

March 4-5, 2013

Karlsruhe Institute of Technology (Campus North)

Organizers:

Hendrik Hölscher (Institute of Microstructure Technology, KIT)

Thomas Schimmel (Institute of Nanotechnology, KIT)

Invited Speakers:

Daniel Ebeling (University of Maryland)

Andreas Günther (University of Tübingen)

Shigeki Kawai (University of Basel)

Angelika Kühnle (University of Mainz)

Tilman Schäffer (University of Tübingen)

Abstract Submission:

Abstracts for oral and poster contributions will be accepted till **January 22, 2013**.

Please send your one-page abstract (*.doc or *.pdf) via email to hendrik.hoelscher@kit.edu.

Registration:

Please register by sending the registration form to hendrik.hoelscher@kit.edu. The number of attendees is limited. The registration fee for the workshop is 100 €. A reduced fee for students is available at 50 €. Deadline for registration is **February 17, 2013**.

Accommodation:

Rooms are available at the Renaissance Karlsruhe Hotel at the special rate of € 95 for a single or € 114 for a double room. As the contingent is limited, we recommend making your reservation as early as possible by contacting the hotel directly at the following address: Renaissance Karlsruhe Hotel, Mendelssohnplatz, 76131 Karlsruhe, Tel.: +49 721 3717-381, Fax: +49 721 3717-333.

To receive the special rates, which both include breakfast, mention the code "AFM-Workshop".

Best Poster Award:

A Best Poster Award of 300 €, 200 €, and 100 € will be granted to the authors of the three best poster presentations by SPECS Surface Nano Analysis GmbH.



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